Amendments to the Claims:

The following listing replaces all prior listing of claims in the application.

Listing of Claims:

- (Previously presented) A method of fabricating a stacked structure comprising the following sequential steps:
- selecting a first plate and a second plate such that a surface portion
 of the first plate has a roughness such that the surface portion is incapable of sticking to
 a surface of the second plate.
- b) producing a sacrificial layer on at least a part of the surface of the first plate or the surface of the second plate, and
 - bonding the first and second plates together,

the method further comprising a step of at least partly eliminating the sacrificial layer to expose the surface portion such that the surface portion at least partially faces the second plate.

2. - 4. (Cancelled)

- (Previously presented) The method according to claim 1 wherein selecting
 a first plate and a second plate further comprises forming the surface having a
 roughness by increasing the roughness of the selected first or second plate to greater
 than approximately 0.2 nm root-mean-square (RMS).
- (Previously presented) The method according to claim 1 wherein selecting comprises selecting a least one of the plates that initially includes a surface layer.
- (Previously presented) The method according to claim 6, wherein selecting further comprises selecting at least one of the plates wherein the surface layer comprises a monocrystalline surface layer.

 (Previously presented) The method according to claim 6 wherein selecting further comprises selecting at least one of the plates wherein the surface layer comprises silicon.

9. - 10. (Cancelled)

- (Previously presented) The method according to claim 1 further comprising forming a surface layer comprising silicon nitride on one of the first or second plates.
- 12. (Previously presented) The method according to claim 1 further comprising smoothing at least one of a free surface of the sacrificial layer or a free surface of at least one of the plates before the bonding.
- 13. (Previously presented) The method according to claim 1 further comprising smoothing the free surface of the sacrificial layer and the free surface of at least one of the plates before the bonding.
- (Previously presented) The method according to claim 1 wherein bonding comprises molecular bonding.
- (Previously presented) The method according to claim 1 wherein bonding comprises bonding with a sacrificial bonding agent.
- 16. (Previously presented) The method according to claim 1 wherein bonding further comprises bonding assisted by at least one of a mechanical means, a plasma treatment, or a thermal treatment.
- (Previously presented) The method according to claim 1 wherein the method further comprises applying a selected atmosphere before bonding.
- (Previously presented) The method according to claim 16 wherein assisting further comprises applying a selected atmosphere during bonding.

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- (Previously presented) The method according to claim 16 wherein bonding further comprises exposing the two plates to an open air environment before bonding.
- 20. (Previously presented) The method according to claim 16 wherein bonding further comprises bonding in an open air environment.
- (Previously presented) The method according to claim 1 further comprising thinning at least one of the first or second plates after bonding.
- (Previously presented) The method according to claim 1 wherein a major portion of at least one of the plates comprises a semiconductor material.
- 23. (Previously presented) The method according to claim 22 wherein the major portion comprises silicon.
- (Previously presented) The method according to claim 1 wherein the sacrificial layer comprises silicon oxide.
- (Previously presented) The method according to claim 1 wherein the sacrificial layer comprises a polymer.
- 26. (Previously presented) A stacked structure fabricated by a method according to claim 1.
 - 27. 41. (Cancelled)